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## BIB DATA SHEET

CONFIRMATION NO. 3611

<b>SERIAL NUMBER</b> 10/550,855	<b>FILING or 371(c) DATE</b> 09/18/2006 <b>RULE</b>	<b>CLASS</b> 118	<b>GROUP ART UNIT</b> 2813	<b>ATTORNEY DOCKET NO.</b> PUS-E005-013	
<b>APPLICANTS</b> Hans Von Kaenel, Zurich, SWITZERLAND; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/EP03/03136 03/26/2003 <b>** FOREIGN APPLICATIONS *****</b> <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** ** SMALL ENTITY **</b> 09/26/2006					
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /SONYA D MCCALL SHEPARD/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> SWITZERLAND	<b>SHEETS DRAWINGS</b> 6	<b>TOTAL CLAIMS</b> 23	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> MOETTELI & ASSOCIATES SARL ST. LEONHARDSTRASSE 4 ST. GALLEN, CH-9000 SWITZERLAND					
<b>TITLE</b> Formation of thin semiconductor layers by low-energy plasma enhanced chemical vapor deposition and semiconductor heterostructure devices					
<b>FILING FEE RECEIVED</b> 590	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		